

FIG.1

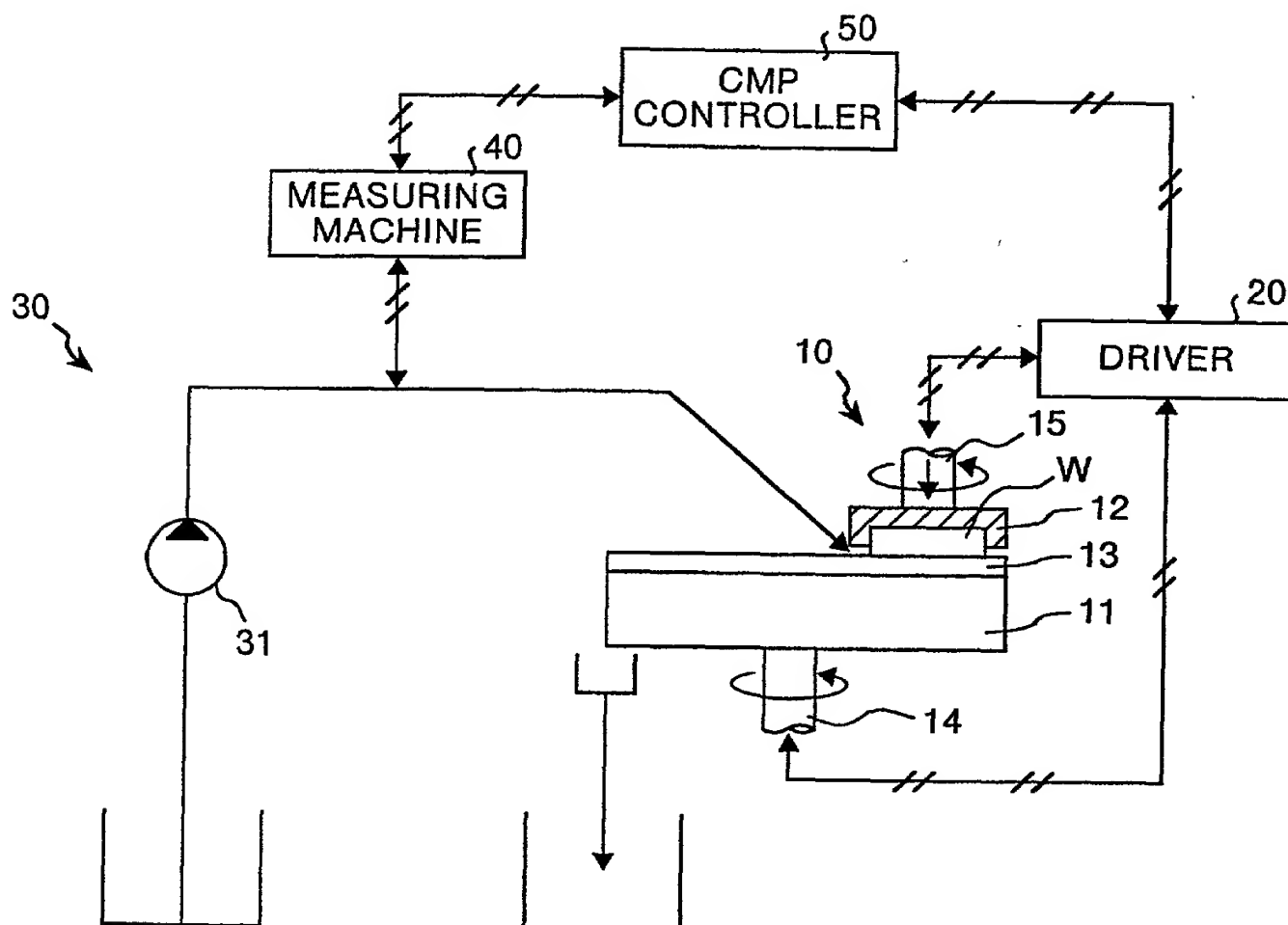


FIG.2

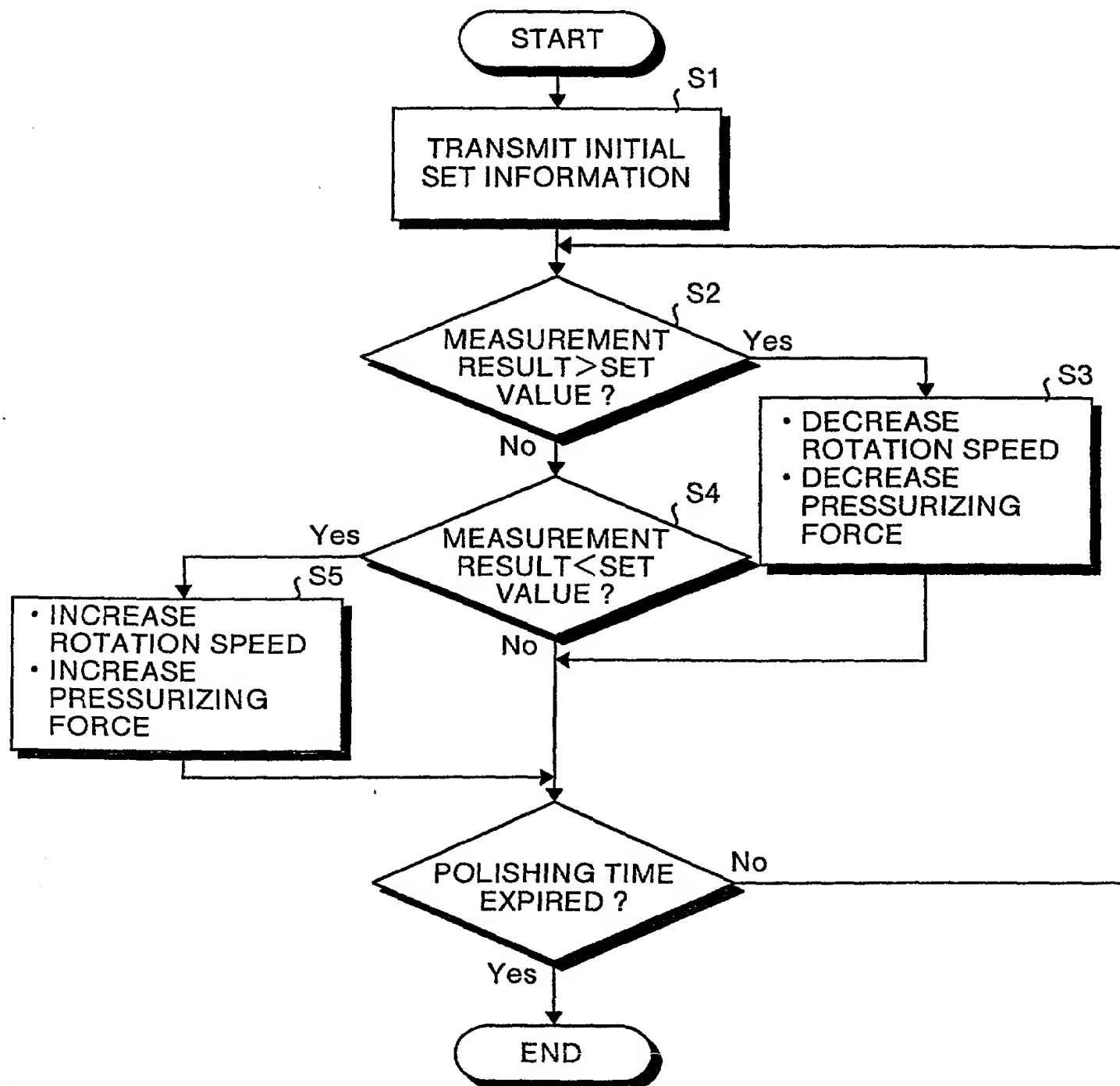


FIG.3

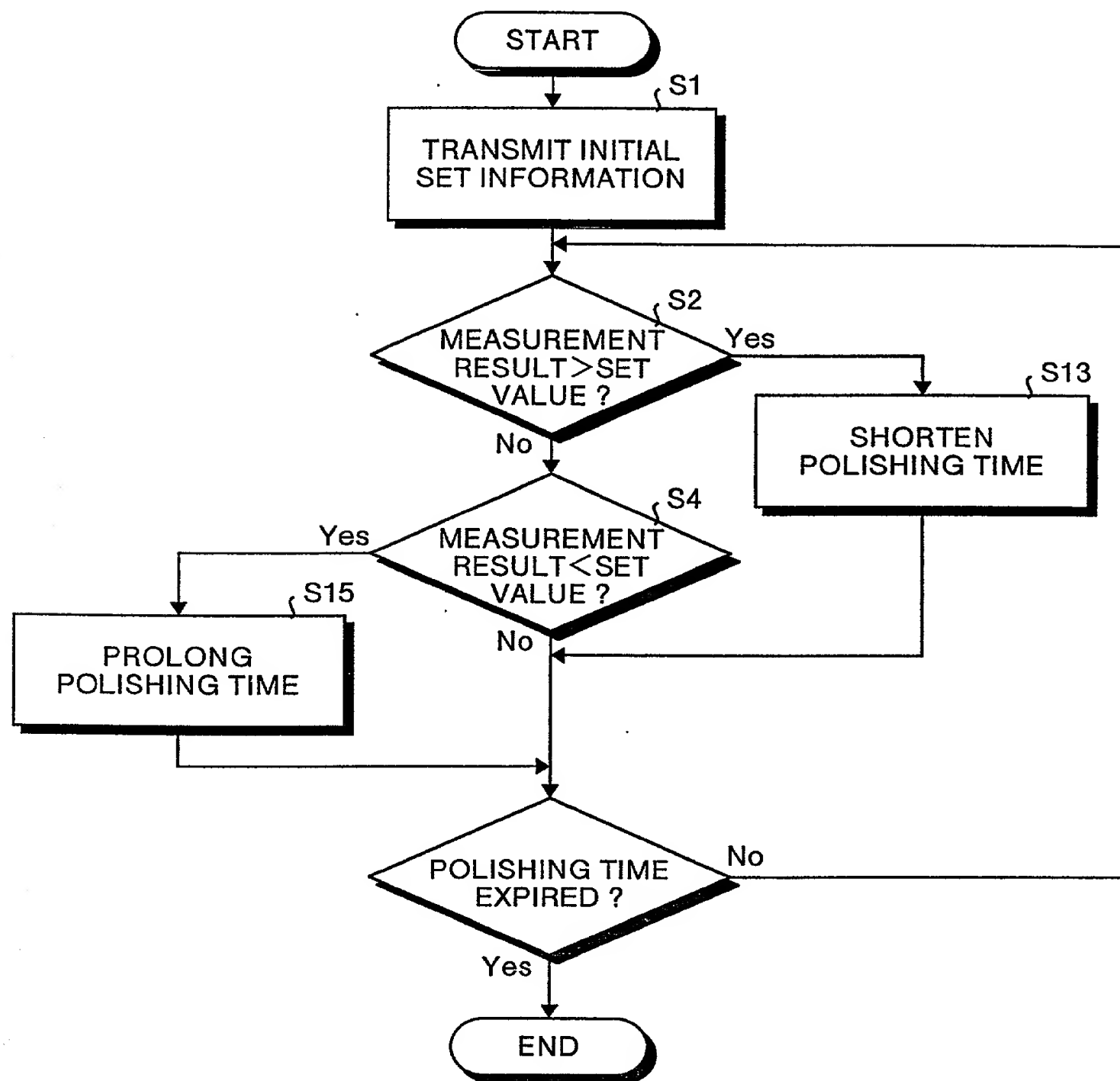


FIG.4

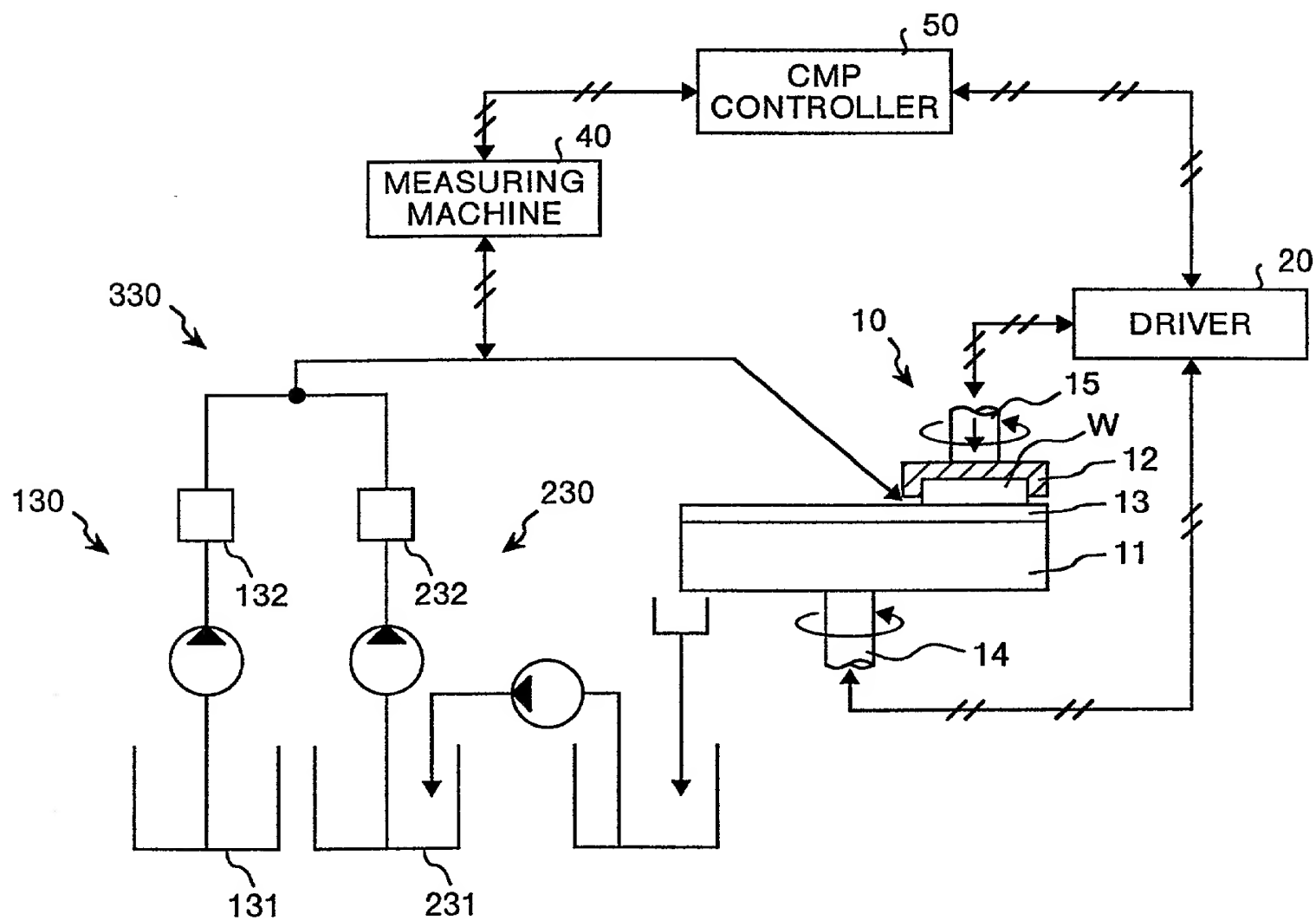
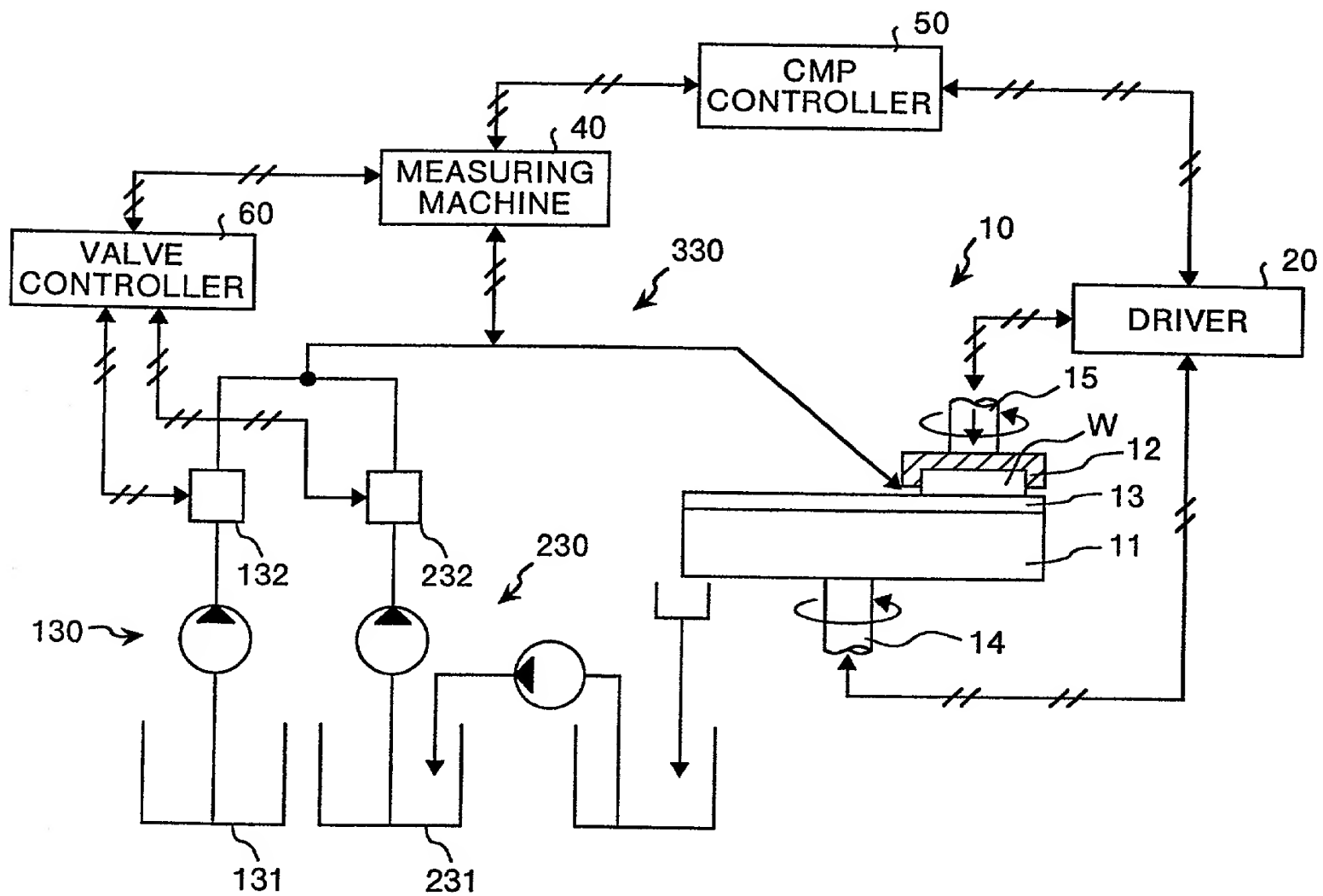


FIG.5



Title: METHOD OF AND APPARATUS FOR CHEMICAL MECHANICAL POLISHING, AND SLURRY
SUPPLYING DEVICE

Inventors: Kazuniro TANAKA

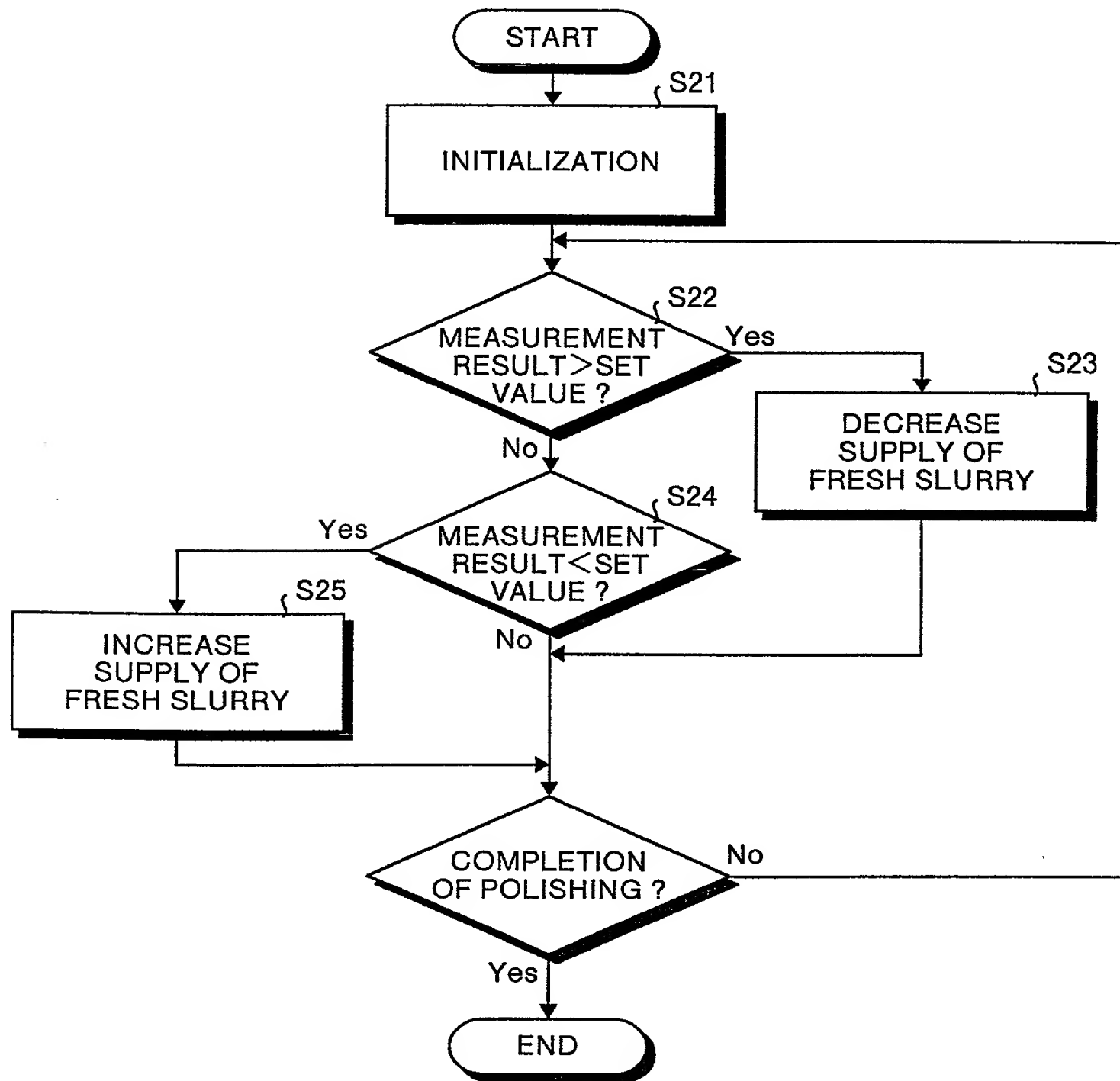
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FIG.6



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FIG.7A

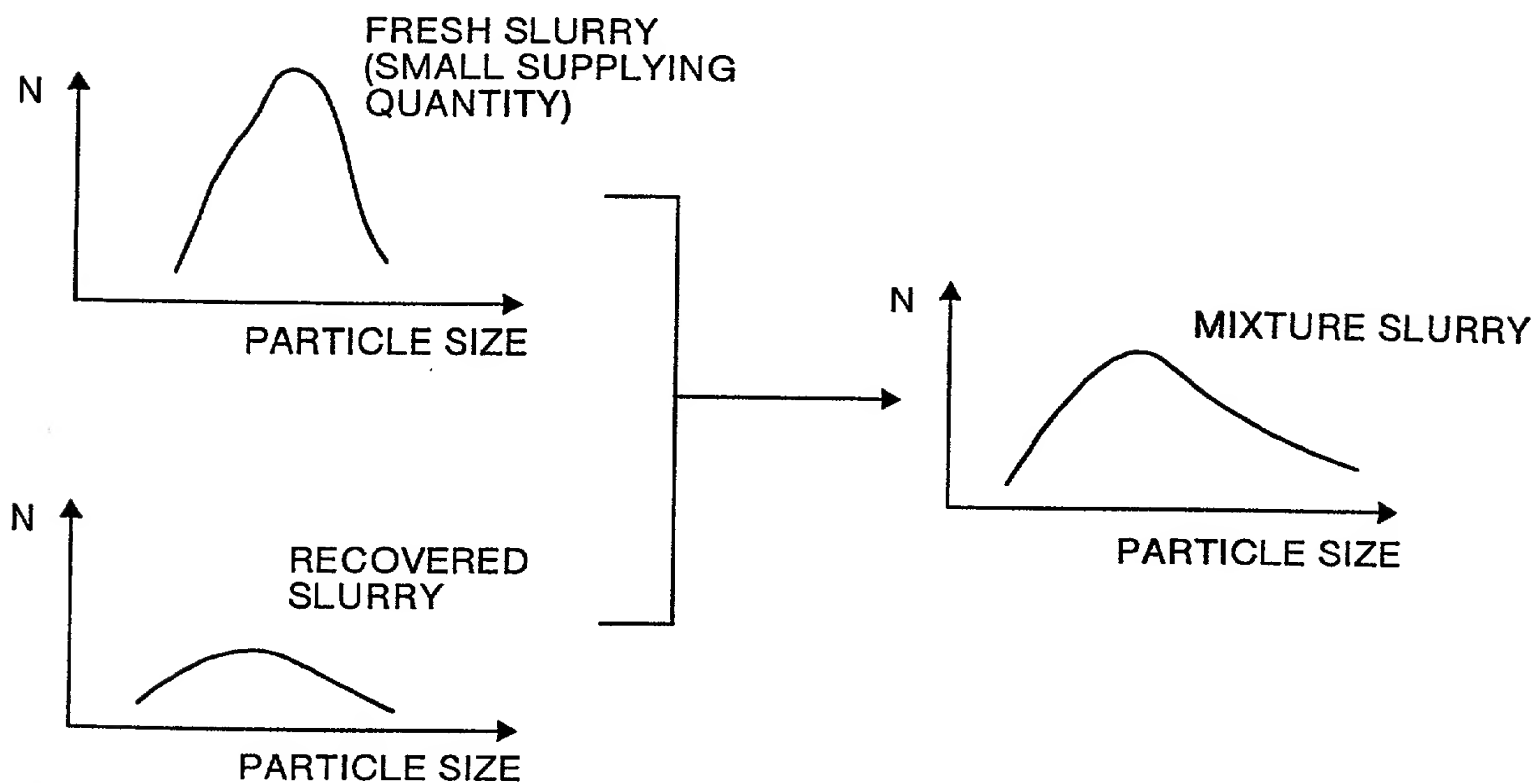
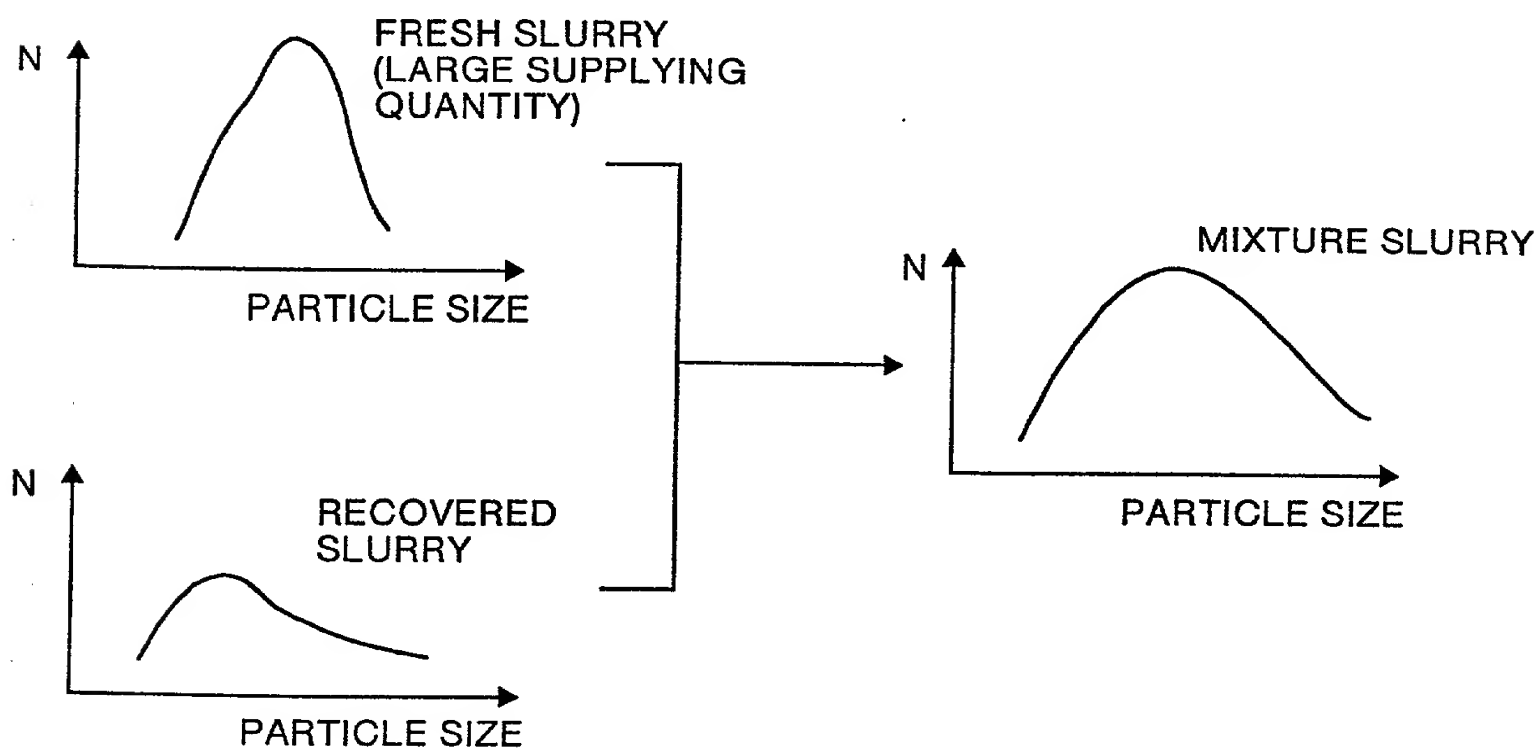


FIG.7B



Title: METHOD OF AND APPARATUS FOR CHEMICAL MECHANICAL POLISHING, AND SLURRY
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Inventors: Kazuniro TANAKA

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FIG.8

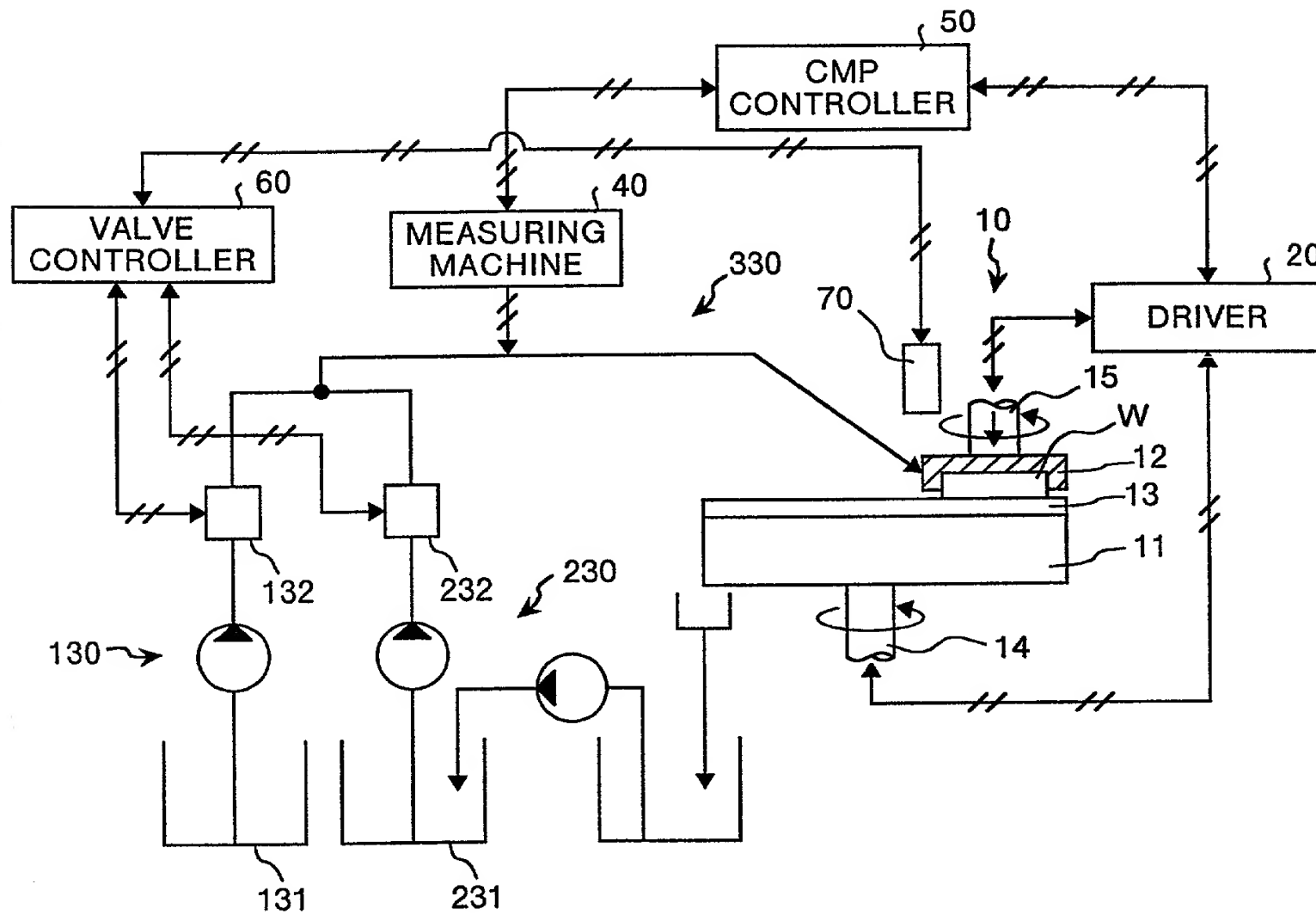
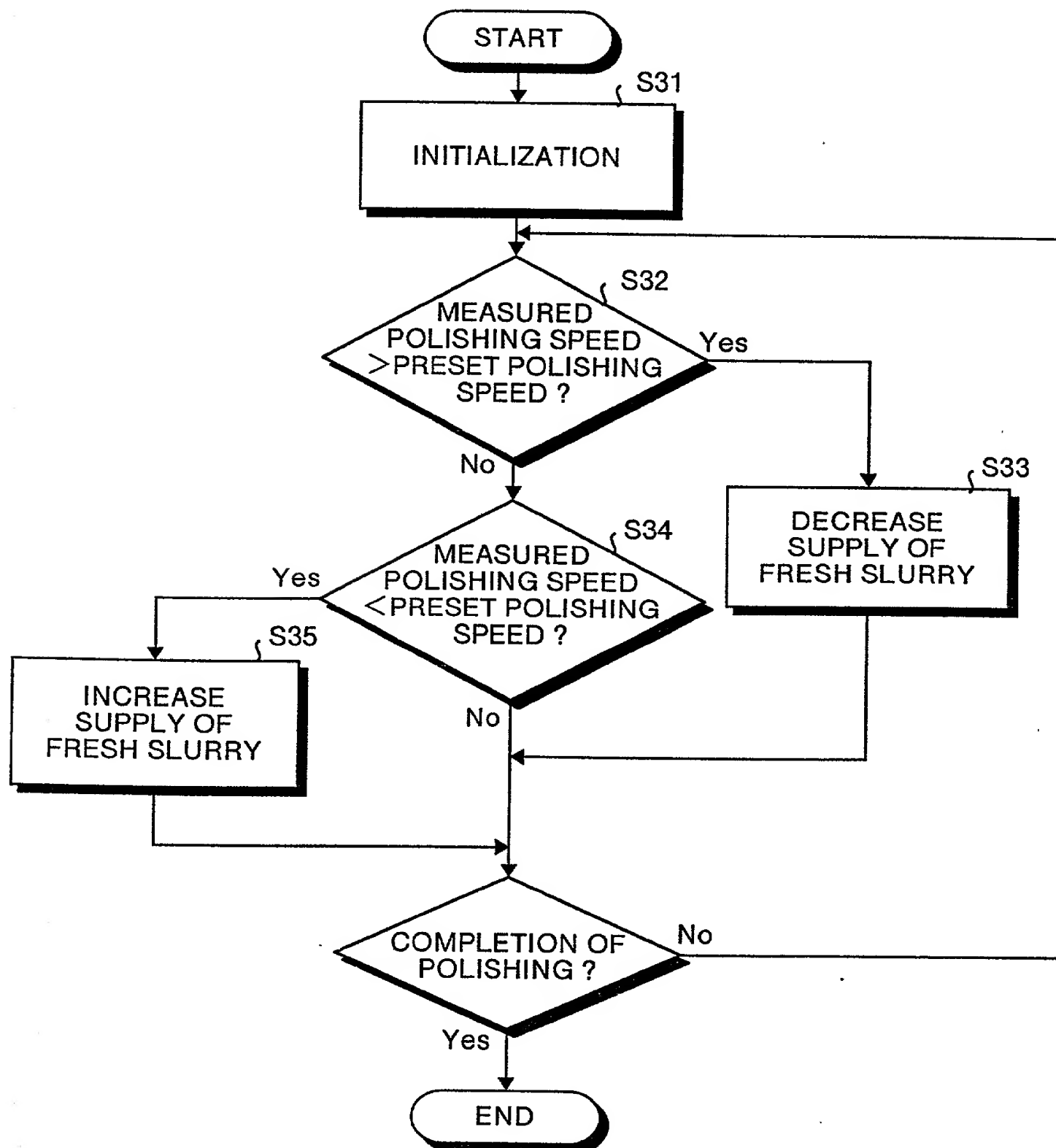


FIG.9



Title: METHOD OF AND APPARATUS FOR CHEMICAL MECHANICAL POLISHING, AND SLURRY
SUPPLYING DEVICE

Inventors: Kazuniro TANAKA

Atty Docket No.: 401384

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FIG.10A

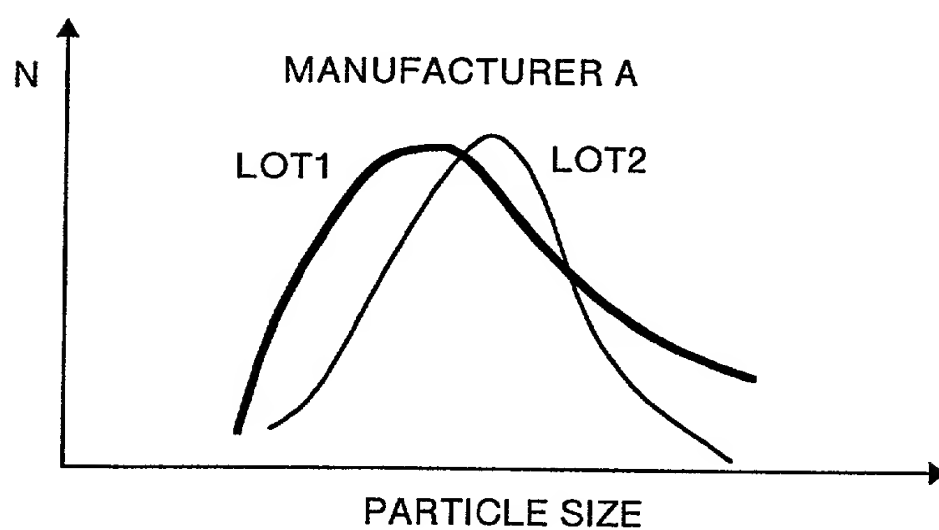


FIG.10B

